

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2612	capacitor and cvd and pvd	US_PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/12/03 08:27
L2	2401	I1 and semiconductor	US_PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/12/03 08:27
L3	2	(cvd and pvd) near (top or upper)	US_PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/12/03 08:28
L4	1715	(cvd and pvd) same (top or upper)	US_PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/12/03 08:28
L5	558	I2 and I4	US_PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/12/03 08:29